



A35109 PCT USA (067515,0161)

OP-28/2

#9 / Supp
IDS
6-10-03
Estola

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Bong-Cheol Kim
Serial No. : 10/089,479 Examiner: Nhu, David
Filed : March 28, 2002 Group Art Unit: 2812
For : APPARATUS AND METHOD FOR FORMING SINGLE
CRYSTALLINE NITRIDE SUBSTRATE USING HYDRIDE
VAPOR PHASE EPITAXY AND LASER BEAM

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

I hereby certify that this paper is being deposited with the United States
Postal Service as first class mail in an envelope addressed to:
Commissioner for Patents, Washington, D.C. 20231

June 2, 2003

Date of Deposit

James J. Maune

Attorney Name

[Signature]
Signature

26,946

PTO Registration No.

June 2, 2003

Date of Signature

Commissioner for Patents
P.O. BOX 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to the provisions of 37 C.F.R. §§ 1.97 and 1.98, Applicant
respectfully requests that the references relating to the above-mentioned application listed
on attached PTO Form 1449, be made of record in the U.S. Patent and Trademark office.

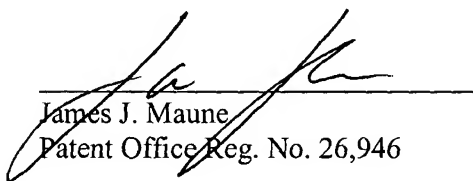
Copies of the referenced citations are enclosed. These documents were cited in the

RECEIVED
JUN -5 2003
TECHNOLOGY CENTER 2800

European Search Report, a copy of which is also enclosed, which was mailed on April 16, 2003.

No fee is believed to be required in connection with this communication. However, if a fee is required, the Commissioner is hereby authorized to charge the payment of any fees to Deposit Account No. 02-4377.

Respectfully submitted,

A handwritten signature in black ink, appearing to read 'James J. Maune', is written over a horizontal line. The signature is stylized with a large initial 'J' and a long, sweeping underline.

James J. Maune
Patent Office Reg. No. 26,946

Attorney for Applicant
(212) 408-2566

Enclosures

